



Applicant(s):

T. ONO, et al

Serial No.:

09/691,119

Filed:

October 19, 2000

For:

METHOD AND APPARATUS FOR TREATING SURFACE OF

SEMICONDUCTOR

Group:

1763

Examiner:

A. Olsen

PETITION FOR EXTENSION OF TIME

Commissioner of Patents Washington, D.C. 20231

February 3, 2003

Sir:

In the matter of the above-identified application, applicant(s) hereby respectfully petition for an extension of time to permit filing of a response within the first month subsequent to the shortened statutory period set in the outstanding Office Action mailed October 3, 2002. A payment in the amount of \$110.00 to cover the required fee for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (520.36911VX1).

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110.00 OP

Respectfully submitted,

Melvin Kraus

Registration No. 22,466

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FEB II 2003